



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

VAN BUEL

Appl. No.: 10/795,801

Filed: March 9, 2004

For: **Lithographic Apparatus and
Device Manufacturing Method**

Confirmation No.: 7706

Art Unit: 1756

Examiner: Daborah Chacko-Davis

Atty. Docket: 1857.2720000

Amendment and Reply Under 37 C.F.R. § 1.111

Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated **October 6, 2005**, Applicant submits the following Amendment and Reply.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefore (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.

Tsn



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*Admitted only in Maryland
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December 29, 2005

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Art Unit 1756

Attn: Mail Stop Amendment

Re: U.S. Utility Patent Application
Application No. 10/795,801; Filed: March 9, 2004
For: **Lithographic Apparatus and Device Manufacturing Method**
Inventor: Henricus Wilhelmus Maria VAN BUEL
Our Ref: 1857.2720000

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Amendment and Reply Under 37 C.F.R. § 1.111; and
2. Return postcard.

It is respectfully requested that the attached postcard be stamped with the date of filing of these documents, and that it be returned to our courier. In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

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JDE/lvt
Enclosures